

UNITED STATES PATENT AND TRADEMARK OFFICE  
**CERTIFICATE OF CORRECTION**

PATENT NO. : 6,872,950 B2  
DATED : March 29, 2005  
INVENTOR(S) : Yasuhiro Shimada et al.

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title page,

Item [56], **References Cited**, U.S. PATENT DOCUMENTS,

"6,381,072 B1 4/2002 Burger.....359/622" should be deleted.

OTHER PUBLICATIONS, third reference, "Arrayed Miniature Electron Beam Columns for High Throughput Sub-100 nm Lithography," T. H. P. CHang, et al., Journal of Vacuum Science and Technology B, vol. 10, No. 6, Nov./Dec. 1992, pp. 2743-2748." should read -- "Arrayed Miniature Electron Beam Columns for High Throughput Sub-100 nm Lithography, T. H. P. Chang, et al., Journal of Vacuum Science and Technology B, vol. 10, No. 6, Nov./Dec. 1992, pp 2743-2748. --.

Column 19,

Line 10, "sunport" should read -- support --.

Signed and Sealed this

Twentieth Day of September, 2005



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JON W. DUDAS  
*Director of the United States Patent and Trademark Office*